Complete If Known Substitute for form 1449A/PTO 10/718,482 **Application Number** INFORMATION DISCLOSURE November 19, 2003 Filing Date STATEMENT BY APPLICANT First Named Inventor Yang, Xiao Art Unit 2812 (use as many sheets as necessary) Unassigned **Examiner Name** 021713-000400US Attorney Docket Number

xaminer	Cite	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where	
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STA	STATEMENT BY APPLICANT			First Named Inventor	Yang, Xiao
				Art Unit	2812
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Sheet	2	of	3	Attorney Docket Number	021713-000400US

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INFORMATION DISCLOSURE				Filing Date	November 19, 2003	
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